

Atty. Dkt. No. 039262-0165  
**10/594895****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Tadahiro OHMI, et al

Title: PLASMA PROCESSING METHOD AND METHOD FOR  
MANUFACTURING AN ELECTRONIC DEVICE

Appl. No.: Unassigned

International 03/31/2005

Filing Date:

371(c) Date: 09/29/2006

Examiner: Unassigned

Art Unit: Unassigned

**PRELIMINARY AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination of the present Application, Applicant respectfully requests that the application be amended as follows:

**Amendments to the Specification** begin on page 2 of this document.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this document.

**Remarks/Arguments** begin on page 4 of this document.

Please amend the application as follows: